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Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

Listing of Claims:

1-36. (Canceled)

37. (Previously presented) An integrated semiconductor structure comprising:

a multijunction solar cell structure having at least first and second subcells; and
a bypass device integral to a subcell for passing current when the solar cell is
shadowed and having p-type, i-type and n-type layers;

wherein the bypass device and the subcell have an identical sequence of semiconductor layers where each layer in the bypass device has substantially the same composition and thickness as the corresponding layer in the subcell and form an integral semiconductor body.

38. (Previously presented) The structure as defined in claim 37, wherein said structure includes a substrate, wherein the subcells are formed on a first portion of the substrate and said bypass device includes a bypass diode formed on a second portion of the substrate.

39. (Previously presented) The structure as defined in claim 38, wherein layers of the subcells are epitaxially grown in a first process and active layers of said bypass diode are epitaxially grown over the layers of the subcells in a subsequent second process.

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40. (Previously presented) The structure as defined in claim 39, wherein said epitaxially

grown diode is electrically connected across at least said first and second subcells to protect such

first and second subcells against reverse biasing.

41. (Previously presented) The structure as defined in claim 39, wherein the bypass diode

includes a metal/semiconductor contact.

42. (Previously presented) The structure as defined in claim 41, wherein the

metal/semiconductor contact is TiAu with InGaP.

43. (Previously presented) The structure as defined in claim 41, wherein the

metal/semiconductor contact forms a Schottky junction.

44. (Previously presented) The structure as defined in claim 38, wherein the substrate is

Ge.

45. (Currently Amended) The structure as defined in claim 37, wherein the second solar

subcell is fabricated at least in part with comprises InGaP.

46. (Currently Amended) The structure as defined in claim 37, wherein the first solar

subcell is fabricated at least in part with comprises GaAs.

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47. (Currently Amended) A solar cell semiconductor device comprising:

a semiconductor body having a sequence of layers of semiconductor material including a

first region in which the sequence of layers of semiconductor material forms a sequence of cells

of a multijunction solar cell with the top layer of the top cell having a first polarity; and

a second region in which the sequence of layers is laterally spaced apart and laterally

separated from said first region and in which the sequence of layers forms a support for an

integral bypass diode to protect said sequence of cells against reverse biasing at less than

breakdown voltage, the bottom layer of the bypass diode having said first polarity

wherein the first region and the second region have an identical sequence of layers where

each layer in the first region has substantially the same composition and thickness as the

corresponding layer in the second region and form an integral semiconductor body.

48. (Previously presented) A device as defined in claim 47, wherein the sequence of

layers of one of said cells and the sequence of layers of the bypass diode are epitaxially grown in

the same process step.

49. (Currently Amended) A device as defined in claim 47, wherein the semiconductor

body includes a Ge substrate, and at least one of the solar cells is fabricated at least in part with

comprises GaAs.

50. (Currently Amended) A solar cell semiconductor device comprising:

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a semiconductor structure having a sequence of layers of semiconductor material including a first region in which the sequence of layers of semiconductor material forms a sequence of subcells of a multijunction solar cell where the top layer of the top subcell has a first

polarity; and

a second region in which the sequence of layers is laterally separated from said first

region by a trough in said sequence of layers and in which the sequence of layers forms a support

for an integral bypass diode to protect the multijunction solar cell against reverse biasing by

allowing current to pass when the solar cell is shadowed where the bottom layer of the bypass

diode has the same polarity as said first polarity of said top subcell; wherein

the bypass device and the subcell have an identical sequence of semiconductor layers where each layer in the bypass device has substantially the same composition and thickness as

the corresponding layer in said top subcell and form an integral semiconductor body.

51. (Previously presented) A device as defined in claim 50, wherein the sequence of

layers of semiconductor material and the sequence of layers of the bypass diode are epitaxially

grown in a different process step.

52. (Currently Amended) A device a defined in claim 50, wherein the semiconductor

structure includes a Ge substrate, and at least one of the cells is fabricated at least in part with

comprises GaAs.

53. (Previously presented) A device as defined in claim 50, further comprising

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a lateral conduction layer lying over said layers of said second region for electrically

connecting the multijunction solar cell to said bypass diode.

54. (Previously presented) The device as defined in claim 53, wherein said structure

includes a substrate, wherein the subcells are formed on a first portion of the substrate and said

bypass diode is formed on a second portion of the substrate over said lateral conduction layer.

55. (Previously presented) The device as defined in claim 53, wherein the solar cell and

lateral conduction layer are epitaxially grown in a first process and the active layers of said

bypass diode are epitaxially grown in a subsequent second process.

56. (Previously presented) The device as defined in claim 55, wherein said epitaxially

grown diode is electrically connected across at least first and second of said subcells to protect

such first and second subcells against reverse biasing at less than breakdown voltage.

57. (Previously presented) The device as defined in claim 50, wherein the bypass diode

includes a metal/semiconductor contact.

58. (Previously presented) The device as defined in claim 57, wherein the

metal/semiconductor contact is TiAu with InGaP.

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59. (Previously presented) The device as defined in claim 57, wherein the metal/semiconductor contact forms a Schottky junction.

60. (Previously presented) The device as defined in claim 50, wherein said bypass diode

includes p-type, i-type, and n-type layers.

61. (Previously presented) The device as defined in claim 53, wherein the lateral

conduction layer is an n-doped GaAs layer for conducting electrical current.

62. (Previously presented) The solar device of claim 60, wherein the p-type layer of the

bypass diode is a p-doped GaAs layer and the n-type layer of the bypass diode is an n-doped

GaAs layer.

63. (Previously presented) The solar device of claim 60, wherein the i-type layer of the

bypass diode is a lightly doped GaAs layer for reducing defect breakdown.

64. (Previously presented) The solar device of claim 60, wherein the i-type layer of the

bypass diode is an undoped GaAs layer for reducing defect breakdown.

65. (Previously presented) A solar cell semiconductor device comprising:

a substrate:

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a first sequence of layers of semiconductor material deposited on said substrate, including a first region in which the sequence of layers of semiconductor material forms at least one cell of a multijunction solar cell where the top layer of the top cell has a first polarity;

a second region including said first sequence of layers, and a second sequence of layers that forms a bypass diode to protect said at least one cell against reverse biasing at less than breakdown voltage where the bottom layer of the bypass diode has the same polarity as said first polarity of said top cell;

a metal layer deposited on a portion of said substrate and over at least a portion of said second region for electrically shorting the first sequence of layers of said second region and to electrically connect to said bypass diode in said second region; and

wherein the first region and the second region have an identical sequence of semiconductor layers where each layer in the second region has substantially the same composition and thickness as the corresponding layer in the first region and form an integral semiconductor body.

66. (Previously presented) A device as defined in claim 65, further comprising a lateral conduction layer wherein said metal layer forms a shunt having a first contact on the solar cell and a second contact on the bypass diode, wherein said first contact is connected to the substrate to make an electrical connection to the solar cell and said second contact is connected to a lateral conduction layer to make an electrical connection to the bypass diode.

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67. (Previously presented) A device as defined in claim 65, further comprising a trough

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situated between the solar cell and the bypass diode that provides electrical isolation between the

solar cell and the diode.

68. (Previously presented) A device as defined in claim 66, further comprising a stop etch

layer deposited over the lateral conduction layer.

69. (Previously presented) A device as defined in claim 65, wherein said bypass diode

includes p-type, i-type, and n-type layers.

70. (Previously presented) A device as defined in claim 66, wherein the lateral

conduction layer is an n-doped GaAs layer for conducting electrical current.

71. (Previously presented) A device as defined in claim 69, wherein the p-type layer of

the bypass diode is a p-doped GaAs layer and the n-type layer of the bypass diode is an n-doped

GaAs laver.

72. (Previously presented) A device as defined in claim 69, wherein the i-type layer is a

lightly doped GaAs layer for reducing defect breakdown.

73. (Previously presented) A solar device as defined in claim 69, wherein the i-type layer

is an undoped GaAs layer for reducing defect breakdown.

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74-85. (Cancelled)

86. (Currently Amended) An integrated semiconductor structure comprising:

a multijunction solar cell including first and second solar cells $\underline{\mathbf{on}}$ in a first portion of the

semiconductor structure;

means integral to a second portion of said semiconductor structure overlying said second

portion for passing current when said multijunction solar cell is shaded; and

a metal layer connecting said multijunction solar cell and said means for passing current,

wherein one end of said metal layer is coupled to a base of said first solar cell and another end of

said metal layer is coupled to one terminal of said means for passing current; wherein

the top layer of the top cell has a first polarity;

the bottom layer of the bypass diode means integral to the second portion has the same

polarity as said first polarity of said top layer of the top cell; and

wherein the first portion and the means integral to the second portion have an identical

sequence of semiconductor layers where each layer in the means integral to the second portion

has substantially the same composition and thickness as the corresponding layer in the first

portion and form an integral semiconductor body.

87. (Previously presented) The structure as structure as defined in claim 86, wherein said

first solar cell is formed on a first portion of the substrate, and said means for passing current is a

bypass diode formed on a second portion of the substrate.

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88. (Previously presented) The structure as defined in claim 87, wherein said first portion

and said second portion are separated by a trough, and said metal layer lies over said trough.

89. (Previously presented) The structure as defined in claim 86, wherein said first and

second solar cells are grown in a first process and said bypass diode is formed in a subsequent

process.

90. (Currently Amended) A solar cell semiconductor device comprising:

an integral semiconductor body having a sequence of layers of semiconductor material

including a first region in which the sequence of layers of semiconductor material forms a

sequence of cells of a multijunction solar cell, with the top layer of the top cell having a first

polarity; and

a second region in which the sequence of layers is laterally spaced apart and laterally

separated from said first region and in which the sequence of layers corresponding to the

sequence of layers forming said cells forms a support structure for a bypass diode to protect said

multijunction solar cell against reverse biasing at less than breakdown voltage, said bypass diode

comprising at least one layer, wherein the bottom layer of the bypass diode has the same polarity

as said first polarity of said top layer of said top cell

wherein the first region and the second region have an identical sequence of

semiconductor layers where each layer in the first region has substantially the same composition

and thickness as the corresponding layer in the second region and form an integral.

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91. (Previously presented) A device as defined in claim 90, wherein the sequence of

layers of said multijunction solar cell and the sequence of layers of the support structure are

formed in the same process step.

92. (Currently Amended) A device as defined in claim 90, wherein the bypass diode

comprises GaAs.

93. (Currently Amended) A solar cell semiconductor device comprising:

a substrate;

a sequence of layers of material deposited on said substrate, including a first region in

which the sequence of layers of material forms a plurality of cells of a multijunction solar cell,

and a second region in which the sequence of layers corresponding to the sequence of layers

forming said cells forms a support for a bypass diode to protect said cell against reverse biasing;

and

a planar lateral conduction layer deposited over the sequence of layers in the second

region for making electrical contact to an active region of said bypass diode; wherein

the topmost layer of the topmost cell has a first polarity; and

the bottom layer of the bypass diode has the same said first polarity as said topmost layer

of said topmost cell; wherein

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the first region and the second region have an identical sequence of semiconductor layers

where each layer in the first region has substantially the same composition and thickness as the

corresponding layer in the second region and form an integral semiconductor body.

94. (Previously presented) A device as defined in claim 93, further comprising:

a lateral conduction layer deposited over the sequence of layers in the first region;

wherein said lateral conduction layer in the first region is physically separated from the lateral

conduction layer in the second region.

95. (Previously presented) A device as defined in claim 93, wherein said lateral

conduction layer is a highly doped layer.

96. (Previously presented) A device as defined in claim 95, wherein said lateral

conduction layer is composed of GaAs.

97. (Previously presented) A device as defined in claim 93, further comprising an etch

stop layer, deposited over said lateral conduction layer.

98. (Currently Amended) A device as defined in claim 93, wherein said substrate forms

an electrical connection path between said multijunction solar cell as and said bypass diode.

99. (Previously presented) A device as defined in claim 93, further comprising

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a metal layer deposited on a portion of said substrate and over at least a portion of said

second region and functioning to (i) electrically short layers of said second region, and (ii)

connect the substrate to said lateral conduction layer to complete the electrical circuit between

the multijunction solar cell and the bypass diode.

100. (Previously Presented) A solar cell semiconductor device comprising:

a substrate:

a sequence of layers of semiconductor material deposited on said substrate including a

first region in which the sequence of lavers of semiconductor material forms at least one cell of a

multijunction solar cell, and a second region in which a sequence of layers corresponding to the

sequence of layers forming said at least one cell, forms a bypass diode to protect said cell against

reverse biasing; and

wherein the sequence of layers in the first and second regions includes a lateral

conduction layer including a first portion disposed in said first region, and a second portion

disposed in said second region and physically separated from said first portion and further

wherein:

the topmost layer of the topmost cell has a first polarity;

the bottom layer of the bypass diode has the same polarity as said first polarity of said

topmost cell; and

the first region and the second region have an identical sequence of semiconductor layers

where each layer in the first region has substantially the same composition and thickness as the

corresponding layer in the second region and form an integral semiconductor body.

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101. (Previously presented) A device as defined in claim 100, wherein said lateral

conduction layer is a highly doped layer.

102. (Previously presented) A device as defined in claim 100, wherein said lateral

conduction layer is composed of GaAs.

103. (Previously presented) A device as defined in claim 100, wherein one of the layers

of said sequence of layers is a cap layer, and said lateral conduction layer is disposed directly

over said cap laver.

104. (Previously presented) A device as defined in claim 100, wherein said second

portion of said lateral conduction layer makes electrical contact with a layer of said bypass diode.

105. (Previously presented) A device as defined in claim 100, wherein said bypass diode

comprises an n GaAs layer, and a p GaAs layer disposed over said n GaAs layer.

106. (Previously presented) A device as defined in claim 100, further comprising a metal

layer deposited on a portion of said substrate and over at least a portion of said second region and

functioning to connect the substrate to a portion of said lateral conduction layer for completing

the electrical circuit between the multijunction solar cell and the bypass diode.

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107. (Previously presented) A solar cell semiconductor device comprising:

a substrate;

a sequence of layers of semiconductor material deposited on said substrate, including a

first region in which a lower portion of said sequence of layers of semiconductor material forms

a multijunction solar cell, and a second region in which an upper portion of said sequence of

layers forms a bypass diode to protect said cell against reverse biasing at less than breakdown

voltage; and

a highly conductive lateral conduction layer deposited over the portion of said sequence

of layers forming the multijunction solar cell, for making electrical contact with one layer of said

bypass diode and forming a contact region to allow said bypass diode to be electrically

connected to said multijunction solar cell; wherein

the topmost layer of the topmost cell has a first polarity; and

the bottom layer of the bypass diode has the same polarity as said first polarity of said topmost

cell; and

the first region and the second region have an identical sequence of semiconductor layers

where each layer in the first region has substantially the same composition and thickness as the

corresponding layer in the second region and form an integral semiconductor body.

108. (Previously presented) A device as defined in claim 107, further comprising a metal

layer deposited on a portion of said substrate and over at least a portion of said second region and

functioning to connect the substrate to a portion of said lateral conduction layer for completing

the electrical circuit between the multijunction solar cell and the bypass diode.

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109. (Previously presented) A device as defined in claim 107, wherein said lateral conduction layer includes a first portion disposed in said first region, and a second portion disposed in said second region and separated from the first portion.

110. (Previously presented) A device as defined in claim 107, wherein said lateral conduction layer is composed of GaAs.

111. (Previously presented) A device as defined in claim 109, wherein said second portion of said lateral conduction layer makes electrical contact with a first active layer of said bypass diode.